IFW

**PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re P	atent Application of:	)	Group Art Unit: 2811
	Osamu Goto, et al.	) )	Examiner: Ori Nadav
Application No. 10/606,176		)	I hereby certify that this document is being deposited
Filed:	June 25, 2003	)	with the United States Postal Service as first class mail in an envelope addressed to: MAIL STOP AMENDMENT, Commissioner for Patents, P.O. Box
For:	SEMICONDUCTOR LIGHT EMITTING DEVICE, ITS MANUFACTURING METHOD, SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD	) ) ) )	1450 Alexandria, VA 22313-1450 on January 25, 2005.  Antonietta Musto

MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Dear Sir:

This Response is submitted in response to the Notice of Non-Compliant Amendment mailed January 13, 2005. Applicants respectfully re-submit the Amendments to the claims contained in the Response to the September 23, 2004 Office Action to comply with 37 C.F.R. § 1.121(h).

Respectfully submitted,

Dated: January 25, 2005

Manna N. Saito

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